

<b>Notice of References Cited</b>	Application/Control No. 10/065,362	Applicant(s)/Patent Under Reexamination VISSER ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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**FOREIGN PATENT DOCUMENTS**

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	N	JP-132503	05-2001	Japan	Kirwan et al	F02D-41/04
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